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separated from trench walls and bottom by a dielectric material, the dielectric material including: a silicon nitride layer sandwiched between a first oxide layer adjacent to the trench walls and bottom, and a second oxide layer adjacent to the conductive material, the first oxide layer having a thickness that is substantially greater than that of the second oxide layer.--

IN THE CLAIMS:

Please cancel claims 1-8.

REMARKS

Upon entry of this preliminary amendment, which cancels claims 1-8, claims 9-14 remain pending. Applicant requests examination of the pending claims.